

PATENT

67 AF
2811IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/881,005
Filed: June 14, 2001
Inventor: Horiuchi et al.
Title: **Multi-Layered Semiconductor
Device and Method for
Producing the Same**
Atty Doc. No.: 149-01
Art Unit: 2811
Examiner: Doug Owens

Certificate of Class Mail

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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450 on: August 17,
2004


Dara Salgado

COVER LETTER WITH CERTIFICATE OF FIRST CLASS MAIL

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed and attached hereto are the following:

- 1) Cover Letter with Certificate of Mailing;
- 2) After Final Amendment; and
- 3) Postcard to be date-stamped and returned.

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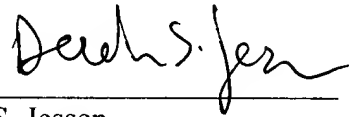
No fees are believed to be required. In the event that an additional fee is required with respect to this communication, the Commissioner is hereby authorized

PATENT

Docket No. 149-01

to charge any additional fees, or credit any overpayment, to Paul & Paul Deposit Account No.16-0750.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Derek S. Jessen", written over a horizontal line.

Date: August 17, 2004

Derek S. Jessen
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Order No.: 2508